

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	("7,019,339").PN.	USPAT; USOCR	OR	OFF	2007/02/20 06:59
L2	4	(virtual near substrate and device near substrate and handle substrate and electrical near contact and strain near compensation).clm.	US-PGPUB; USPAT	OR	OFF	2007/02/20 07:00